

Notice of References Cited	Application/Control No. 10/656,613	Applicant(s)/Patent Under Reexamination JOHNSON ET AL.	
	Examiner Kevin Quinto	Art Unit 2826	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	C	US-			
	D	US-			
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	G	US-			
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	K	US-			
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FOREIGN PATENT DOCUMENTS

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	N	JP 2001-36069 A	02-2001	Japan	Uesugi et al.	-
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NON-PATENT DOCUMENTS

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	U	Wolf, "Silicon Processing for the VLSI Era: Vol. 1 – Process Technology, Lattice Press, 2000, 2 nd edition, p. 226
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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